Living up to Life



Leica EM ACE

New Generation Coaters





Leica EM ACE Coaters

your advanced coating experience...

Developed in cooperation with leading scientists, the new generation of ACE coaters covers all the requirements for your sample preparation needs, from coating to freeze fracture.

Open the door to explore new coating capabilities.

Our philosophy is simple, 'Produce a coating layer easily, fast and reliably, to achieve the best image of your sample in the electron microscope'.

Discover the features

- > One touch coating
- > Small footprint
- > Cryo upgrade
- > Customized configurations
- Intuitive operation
 - › Fully automated

Leica EM ACE – A coater family to cover all your needs

COATING TECHNOLOGY

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Coating of samples is required in the field of electron microscopy to enable or improve the imaging of samples. Creating a conductive layer of metal on the sample inhibits charging, reduces thermal damage and improves the secondary electron signal required for topographic examination in the SEM. Fine carbon layers, being transparent to the electron beam but

The Leica EM ACE one-touch coating systems are available in two versions: The Leica EM ACE200 Low Vacuum coater for general SEM and TEM analysis and the Leica EM ACE600 High Vacuum coater for the highest resolution TEM and FE-SEM analysis. The ACE600 instrument is easily upgraded to a cryo-coater including vacuum cryo transfer. conductive, are needed for x-ray microanalysis, to support films on grids and back up replicas to be imaged in the TEM. The coating technique used depends on the resolution and application. The Leica EM ACE coater family provides the perfect solution for every application.

The instruments are fully automated for the easiest operation. Their compact design and small footprint save lab space whilst delivering operational ergonomy. Protocols can be shared as the touch screen interface supports a multi-user environment. The flexibility of the ACE coaters allows individual systems to be configured to your laboratories exact needs.

Bigger area

Better layer

Best results



LESS...

- > Human interaction time and expert knowledge
- › Footprint
- > Sealing surface one door only
- > Cleaning effort removable door, chamber shielding and shutter
- > Operator effort easy push-fit connectors no tools required

...IS MORE

- > Intuitive touch-screen and automated process run
- > Customized configuration with hardware and software upgrades
- › Lab space
- > Visibility, easy loading and fast vacuum build-up
- > Effective coating to free your working time
- > Homogenous coating, accurate layers and reproducible results

Simple adaptation

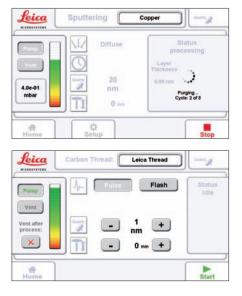
Smallest footprint

Smoothest operation

Sputtering process

Purging the chamber to be followed by sputtering 20 nm copper at a pressure of 8 x 10^{-2} mbar (option diffuse).

Carbon thread evaporation waiting to start. When "Start" is pushed, threads will be degassed and 1 nm carbon will be deposited. Table is on the defined zero position and the instrument is kept under vacuum after finishing the process.





Leica EM ACE200

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Sputter and Carbon Thread Coating for perfectly reproducible results



The Leica EM ACE200 is a high quality desk-top coater designed to produce homogeneous coatings of conductive metal or carbon as required for electron microscopy.

The fully automated instrument can be configured either as a sputter coater or a carbon thread evaporation coater. Or, if preferred, the Leica EM ACE200 can combine both methods with interchangeable heads on the one instrument. Additional options include:

- > Quartz crystal measurement for reproducible layers
- Planetary rotation for even distribution of coating material on fissured samples
- > Glow discharge to make TEM grids hydrophilic
- > Exchangeable shielding for easy cleaning

Small Coaters – Big Features ...

A new era of carbon evaporation Carbon layers, up to 40 nm thick, are defined and accurately deposited using a unique software-controlled, pulsed evaporation procedure in combination

with continuous thickness monitoring (quartz measurement). Carbon layers are therefore highly reproducible and smooth. Easy cleaning with removable door, shutter and internal shielding, source and stage



Leica EM ACE600

High Vacuum Coating - configure your system - we build the coater you need



The Leica EM ACE600 is a versatile high vacuum film deposition system, designed to produce very thin, fine-grained and conductive metal and carbon coatings for the highest resolution analysis, as required for FE-SEM and TEM applications.

This fully automated table-top coater includes an integrated oilfree pumping system, quartz crystal film thickness measurement and three axis motorized stage (rotation, optional tilt and height).

The Leica EM ACE600 can be configured for the following methods:

- Sputtering
- > Carbon thread evaporation
- Carbon rod evaporation (with an option for thermal resistance evaporation)
- > e-beam evaporation
- Glow discharge
- Leica EM VCT adaptation for cryo-coating, freeze-fracture, double-replica, freeze-drying and environmental transfer with the VCT Shuttle

Angled sources and integrated rotation for larger, more evenly coated surfaces. Up to two sources can be configured to your laboratories needs. 3-axis motorized stage control – stage adjustment without breaking v

Integrated quartz measurement centered in the stage for perfectly reproducible results.



Leica EM ACE600 with Leica EM VCT100

Not only a coater - cryo options and VCT connection for the Leica EM ACE600

The Leica EM ACE600 outfitted with a Leica EM VCT100 (vacuum cryo transfer system) is the ideal solution for contamination-free cryo-SEM sample preparation with complete environmental control. Cryo stage and room temperature stages are interchangeable once the coater is cryo-configured. With the VCT100 configuration, the ACE600 connects to other VCT-outfitted instruments such as glove boxes, SEMs and the Leica EM FC7T.

- Transfer under controlled environment (vacuum and temperature)
- > Cryo pump for higher vacuum
- Temperature-controlled stage for freeze fracture, sublimation and freeze drying
- Fracturing knife with motor-driven height adjustment
- > Scalpel for basic fracturing
- > Double replica release







Freeze Fracture, Freeze Etching and Freeze Drying

Freeze fracture includes a series of techniques that reveal and replicate internal components of organelles and other membrane structures for examination in the electron microscope. Freeze etching removes layers of ice by sublimation and exposes membrane surfaces that were originally hidden. Freeze drying, also known as lyophilization, removes water from a frozen sample under high vacuum conditions (sublimation). The result is a dry and stable sample which can be imaged in the electron microscope.

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Male mosquito Courtesy of Mag. Daniela Gruber Core Facility of Cell Imaging and Ultrastructure Research Universität Wien



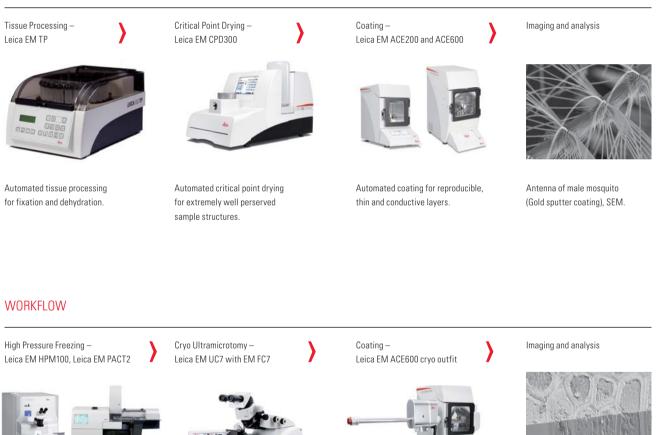
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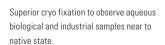
SEM and TEM Workflows

Leica Microsystems offers a complete range of solutions for EM sample preparation. The new Leica EM ACE coaters perfectly enhance these workflows.

Only if each step of sample preparation is of the highest quality, can optimum results be obtained from a high resolution electron microscope.

WORKFLOW







High quality ultrathin sectioning/planing for light, electron, and atomic force microscopy examination.

High vacuum coating in conjunction with Leica EM VCT100 (vacuum cryo transfer) system for the finest metal and carbon layers.



Poplar cambium and xylem



The statement by Ernst Leitz in 1907, "With the User, For the User," describes the fruitful collaboration with end users and driving force of innovation at Leica Microsystems. We have developed five brand values to live up to this tradition: Pioneering, High-end Quality, Team Spirit, Dedication to Science, and Continuous Improvement. For us, living up to these values means: Living up to Life.

Leica Microsystems operates globally in four divisions, where we rank with the market leaders.

LIFE SCIENCE DIVISION

The Leica Microsystems Life Science Division supports the imaging needs of the scientific community with advanced innovation and technical expertise for the visualization, measurement, and analysis of microstructures. Our strong focus on understanding scientific applications puts Leica Microsystems' customers at the leading edge of science.

INDUSTRY DIVISION

The Leica Microsystems Industry Division's focus is to support customers' pursuit of the highest quality end result. Leica Microsystems provide the best and most innovative imaging systems to see, measure, and analyze the microstructures in routine and research industrial applications, materials science, quality control, forensic science investigation, and educational applications.

BIOSYSTEMS DIVISION

The Leica Microsystems Biosystems Division brings histopathology labs and researchers the highest-quality, most comprehensive product range. From patient to pathologist, the range includes the ideal product for each histology step and high-productivity workflow solutions for the entire lab. With complete histology systems featuring innovative automation and Novocastra[™] reagents, Leica Microsystems creates better patient care through rapid turnaround, diagnostic confidence, and close customer collaboration.

MEDICAL DIVISION

The Leica Microsystems Medical Division's focus is to partner with and support surgeons and their care of patients with the highest-quality, most innovative surgical microscope technology today and into the future. Leica Microsystems – an international company with a strong network of worldwide customer services:

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